



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tom Tse, et al.

Title: METHOD AND SYSTEM FOR DOSE CONTROL DURING AN ION IMPLANTATION PROCESS

App. No.: 10/082,567

Filed:

February 25, 2002

Examiner: Mary A. El Shammaa

Group Art Unit:

2881

Atty. Dkt. No.: 1458.TT4763

M/S AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action mailed November 20, 2003 regarding the above captioned patent application, the Applicants hereby respectfully submit the following amendment and response.

OK
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CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on 1-20-04.

KATRINA PRATI
Typed or Printed Name

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Signature